

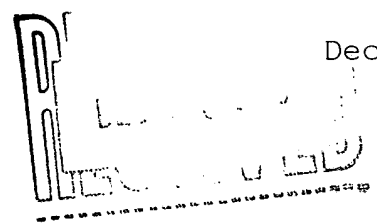
PATENT
2091-0205P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Nobuyoshi NAKAJIMA Conf.: 3582
Appl. No.: 09/447,256 Group: 2623
Filed: November 23, 1999 Examiner: C. LAROSE
For: IMAGE PROCESSING METHOD AND APPARATUS

STATEMENT OF THE SUBSTANCE OF THE INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



December 23, 2003
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DEC 24 2003
Technology Center 2600

Sir:

This statement of the Substance of the Interview is being
filed in accordance with MPEP §713.04.

Applicant's representative conducted a personal interview
with the Examiner, Colin LaRose, and the Primary Examiner,
Amelia Au, on December 11, 2003. During the interview, the
combination of Kobori et al. and Kado et al. was discussed, in
particular Applicant's representative argued that one skilled in
the art would not look towards Kado et al. to make up for the
deficiencies of Kobori et al. An agreement, however, was not
reached.

If necessary, the Commissioner is hereby authorized in this,
concurrent, and future replies, to charge payment or credit any
overpayment to Deposit Account No. 02-2448 for any additional fees

required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By 
D. Richard Anderson, #40,439

DRA/MRG:tm
2091-0205P

P.O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000